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PATENT APPLICATION
SERIAL NO. 10/071,881

ATTORNEY DOCKET NO. 116-020155

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit 2881

In re application of

FUMIO HOSOKAWA ET AL.

Serial No. 10/071,881

Filed February 8, 2002

LENS SYSTEM FOR PHASE PLATE FOR
TRANSMISSION ELECTRON MICROSCOPE
AND TRANSMISSION ELECTRON
MICROSCOPE

Pittsburgh, Pennsylvania
April 25, 2002

CLAIM FOR PRIORITY UNDER 35 U.S.C. §119

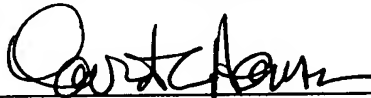
Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant claims priority to Japanese Patent Application No. 2001-033799 which corresponds to the above-identified United States patent application and which was filed in the Japanese Patent Office on February 9, 2001. A certified copy of the priority document will follow. The priority benefits provided by Section 119 of the Patent Act of 1952 are claimed for the above application.

Respectfully submitted,

WEBB ZIESENHEIM LOGSDON
ORKIN & HANSON, P.C.

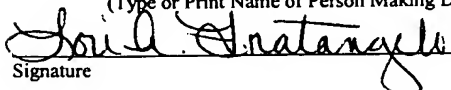
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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, Washington, D.C. 20231 on April 25, 2002.

Lori A. Fratangelo

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 04/25/02
Signature Date